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Practitioner's Docket No. MI22-2514

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: H. Daniel Dulman et al.

Application No.: 10/808,703  
Filed: 03/24/04

Group No.: 1756  
Examiner: S.R. Mohamedulla

For: Methods of Forming Aligned Structures with Radiation-Sensitive Material

Commissioner for Patents  
Washington, D.C. 20231

CERTIFICATION OF FACSIMILE TRANSMISSION

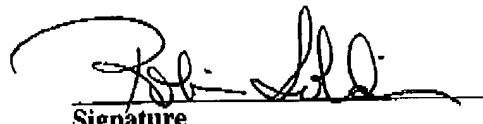
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Total Pages 3

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(Certification of Facsimile Transmission--page 1 of 1)

OCT 04 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 10/808,703  
Filing Date ..... March 24, 2004  
Inventor ..... H. Daniel Dulman et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1756  
Examiner ..... S.R. Mohamedulla  
Attorney's Docket No. .... MI22-2514  
Title: Methods of Forming Aligned Structures With Radiation-Sensitive Material

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References -- See attached Form PTO-1449

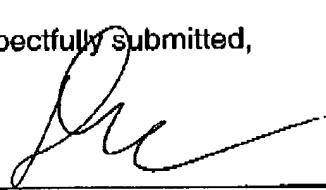
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents listed on the attached Form PTO-1449. Copies of the cited art are not included, only U. S. patents are cited (1276 Off. Gaz. Pat. Off., 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

Please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 10/4/04

  
\_\_\_\_\_  
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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2514	SERIAL NO. 10/808,703		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT H. Daniel Dulman et al.			
				FILING DATE 03/24/04	GROUP 1756		
<b>U.S. PATENT DOCUMENTS</b>							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,312,854 B1	11/01	Chen et al.			
	AB	6,465,198 B1	10/02	Stanton			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Subclass	Translation
	AM						Yes
	AN						No
	AO						
	AP						
	AQ						
<b>OTHER REFERENCES</b> (including Author, Title, Date, Pertinent Pages, Etc.)							
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